

IFW
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Attorney Docket # 5367-141RCE



MS-AF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Tony ALBRECHT et al.

Serial No.: 09/824,086

Filed: April 2, 2001

For: Optically Pumped, Surface-emitting
Semiconductor Laser Device and Method for the
Manufacture Thereof

Examiner: LEUNG, Quyen Phan
Group Art: 2828

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
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January 3, 2005

(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

Signature

January 3, 2005

Date of Signature

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AMENDMENT AFTER FINAL REJECTION

SIR:

This is in response to the Final Rejection dated October 1, 2004, setting a shortened
statutory period for response on January 1, 2005 (Saturday). Please amend the above-identified
application as follows:

Remarks/Arguments begin on page 2 of this paper.